Den

Group Art Unit: 2823

Examiner: Fernando L. Toledo

In Re PATENT APPLICATION of:

Applicant(s): Masaru TAKAISHI

Serial No.: 10/766,212

Filing Date: January 29, 2004

For:

METHOD FOR MANUFACTURING

SEMICONDUCTOR DEVICE

Atty. Ref.:

AI 325

PETITION FOR TWO-MONTH EXTENSION OF

TIME

December 14, 2005

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the period for replying to the Examiner's Action mailed on July 26, 2005, be extended for two month under the provisions of 37 C.F.R. 1.136(a).

The applicable extension fee of \$450.00 pursuant to 37 C.F.R. 1.17(a)(2) is submitted herewith.

Should the remittance be accidentally missing or insufficient, the Commissioner is hereby authorized to charge the fee to our Deposit Account No. 18-0002, and advise us accordingly.

12/15/2005 SZEWDIE1 00000066 10766212

01 FC:1252

450.00 OP

December 14, 2005

Date

Robert H. Berdo, Jr. – Reg. No. 38,075

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Respectfully submitted,

RHB:vm